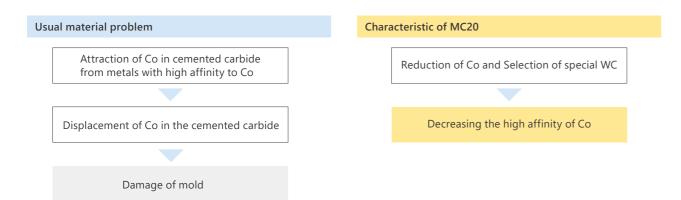
Cemented carbide for stamping of metals high affinity to cobalt - MC20

Cemented carbide for stamping of metals high affinity to cobalt (Adhesive wear-resistance by seizure) Excellent product life against manufacturing for pure iron or copper which are easy to be seizure. Excellent performance for EDM and corrosion-resistance. Adhesive wear and seizure resistance by adopting special WC and reducing binder phase of Co. Excellent high hardness, performance of EDM and corrosion resistance by optimizing WC particle Explanation and composition design. Press mold for lead frame and connector made of copper. • Applications Press mold for SPC type steels.

Breakage resistance for mold demanded high hardness when EDM, etc.



Comparison of reaction to copper (Analysis of EPMA)

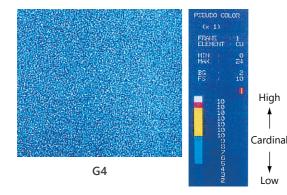
Comparative reaction test between MC20 and G4 grade.

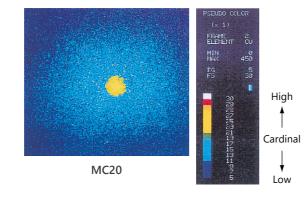
Above-shown photos are the cross-section surface of the test pieces which are compacted wire copper in center of MC20 and G4 after sintering and treated by HIP.

Result;

MC20: Copper wire remains in the original position without diffusing.

G4: Copper wire has diffused in the material.





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Physical property of MC20					
Our grade	WC grain size [µm]	Co content [%]	Density [×10 ³ kg/m ³] {g/cm ³ }	Hardness HRA	

6

8

14.9

14.8

MC20

G3

2.5 - 5.0

1.0 - 2.5

(Typical figures)

90.0

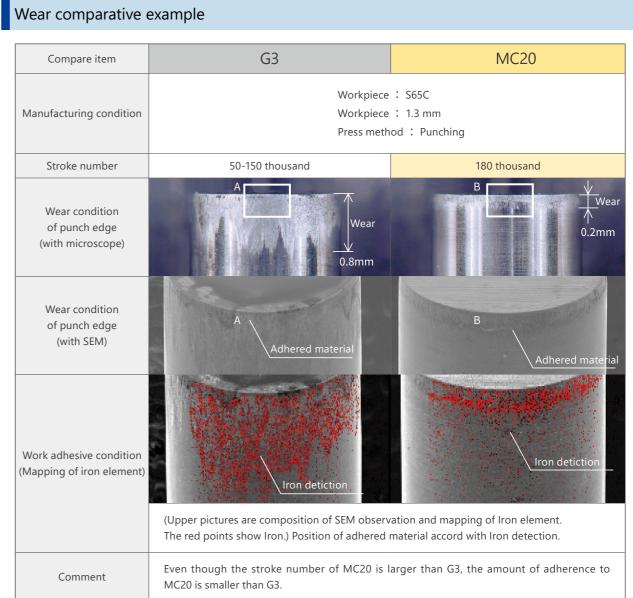
90.0

TRS*

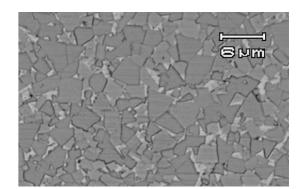
[GPa]

2.8

2.7







By metallurgical microscope (×1000)